

<b>Notice of References Cited</b>	Application/Control No. 10/695,492	Applicant(s)/Patent Under Reexamination JOHNSON, DAVID A.	
	Examiner Hai C. Pham	Art Unit 2861	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0128381	07-2003	Zaima, Nobuhiko	358/1.9
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